

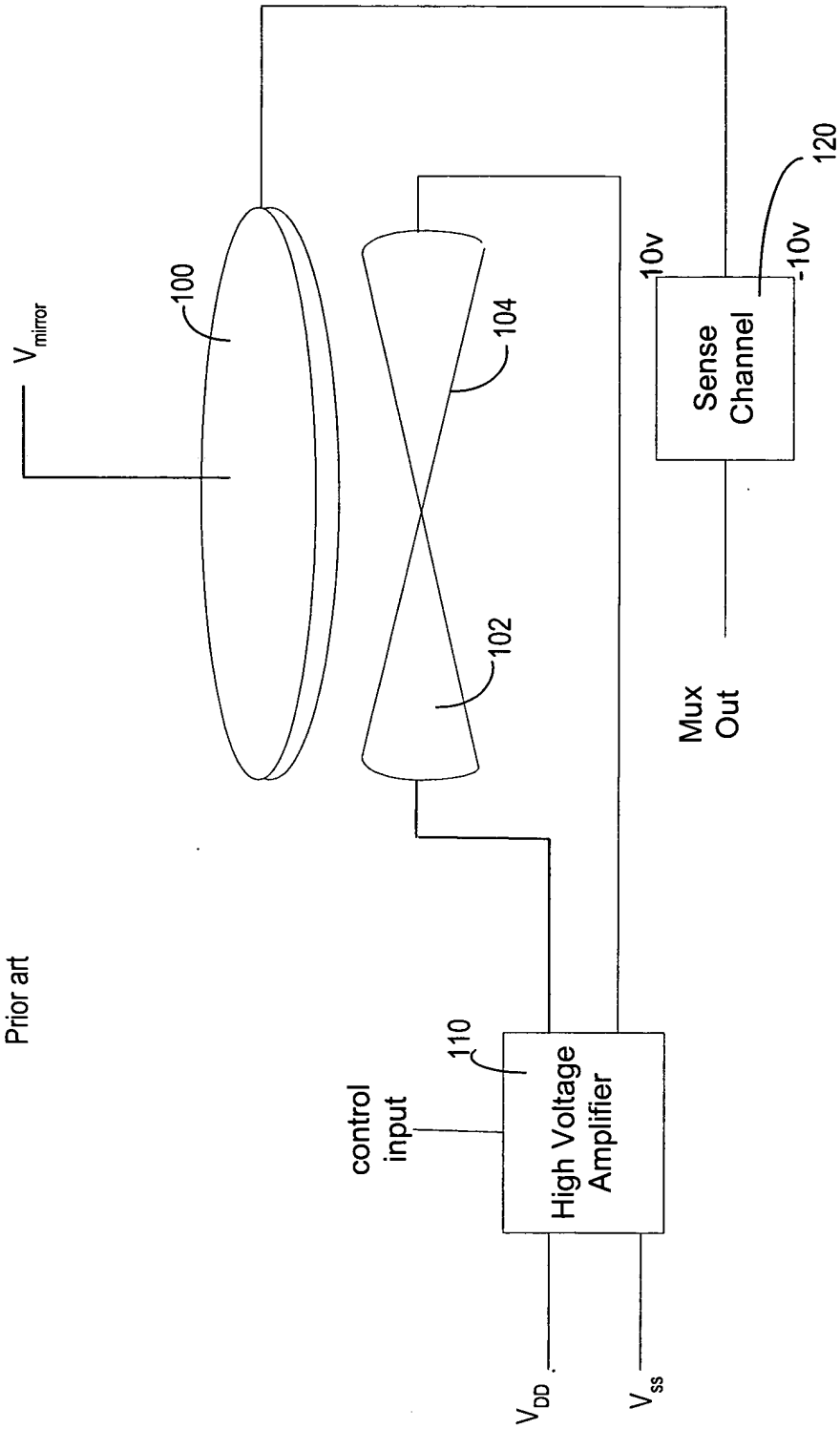
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Roessig, et al.
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Herewith
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Docket No.:
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Larry E. Viera
(415) 369-9660

Figure 1
Prior art

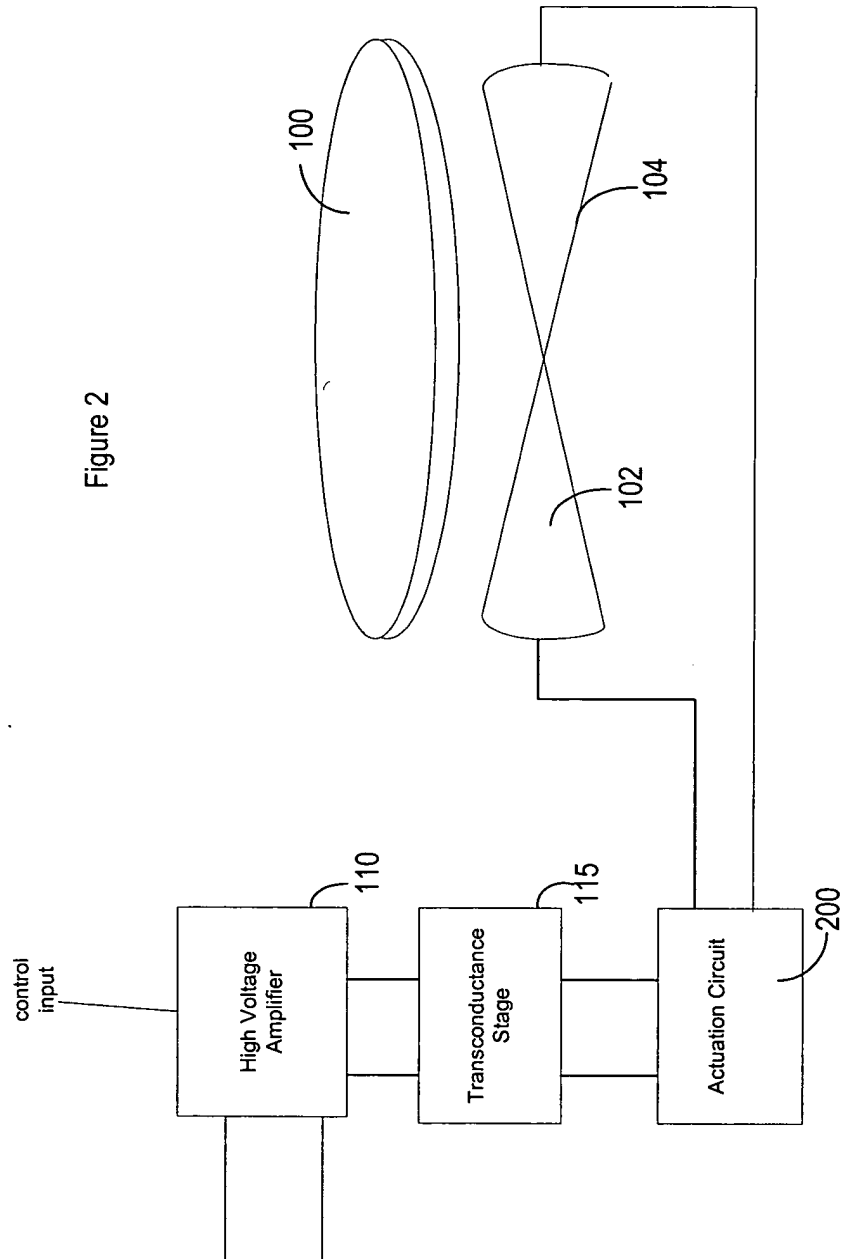


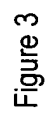
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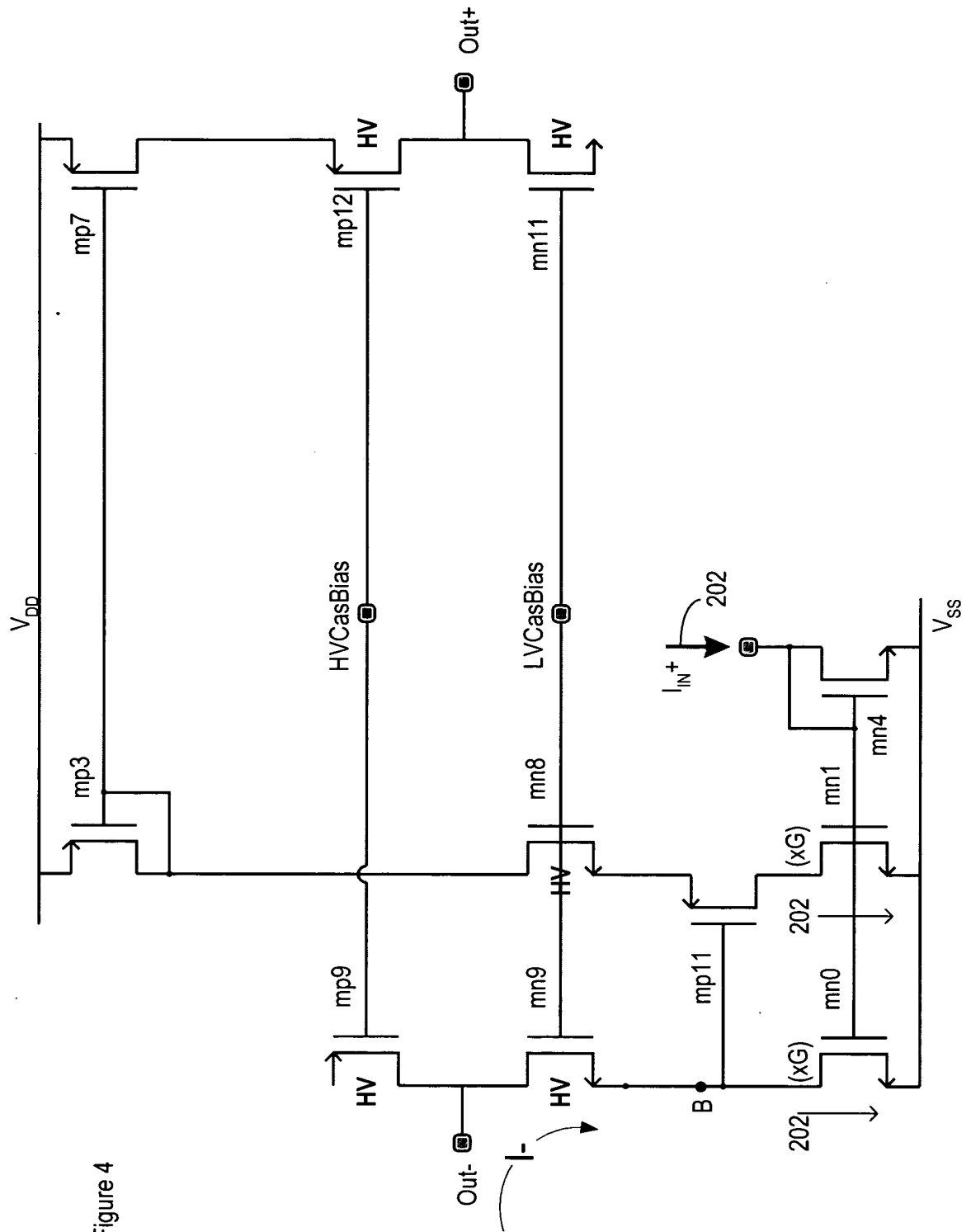


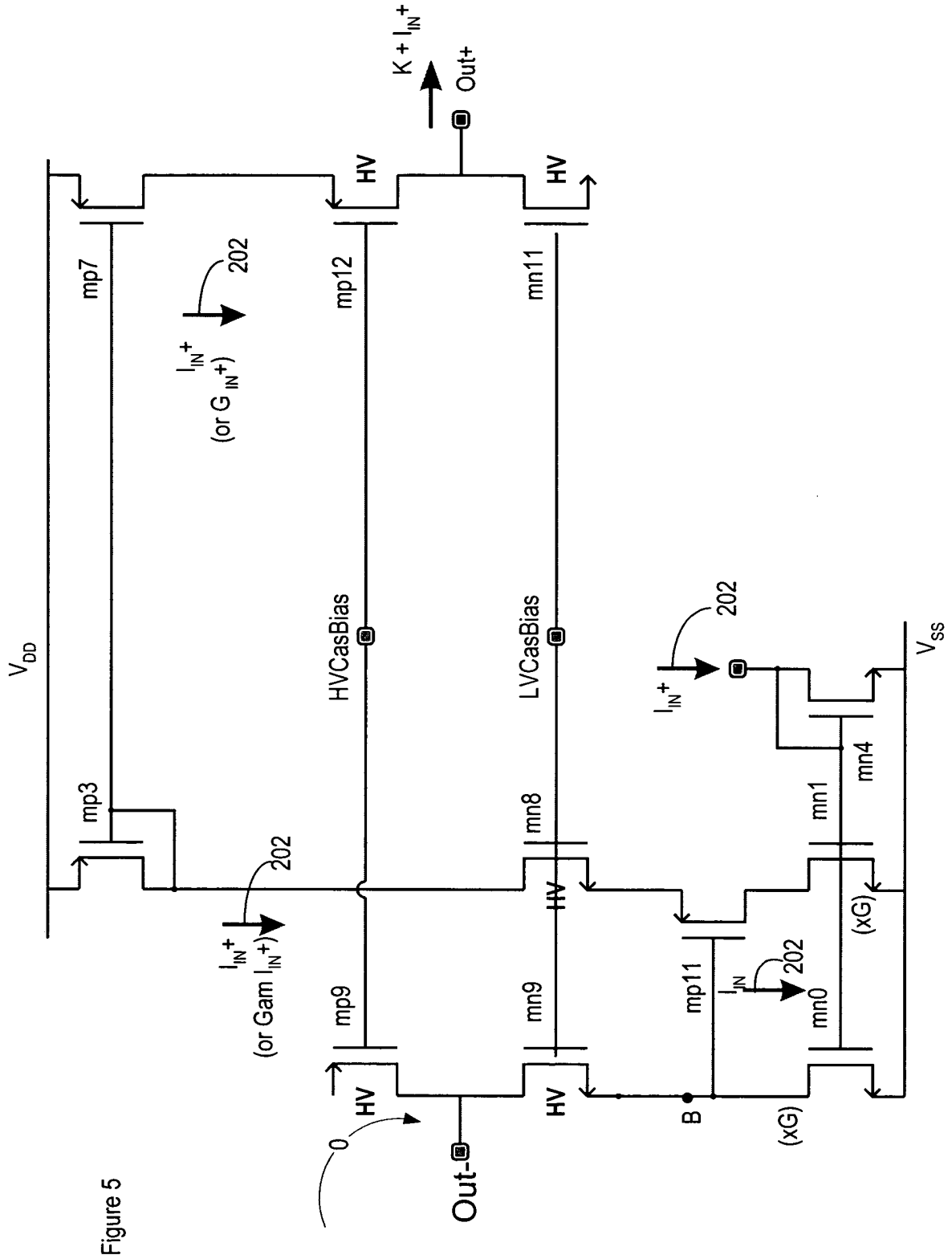
Figure 4

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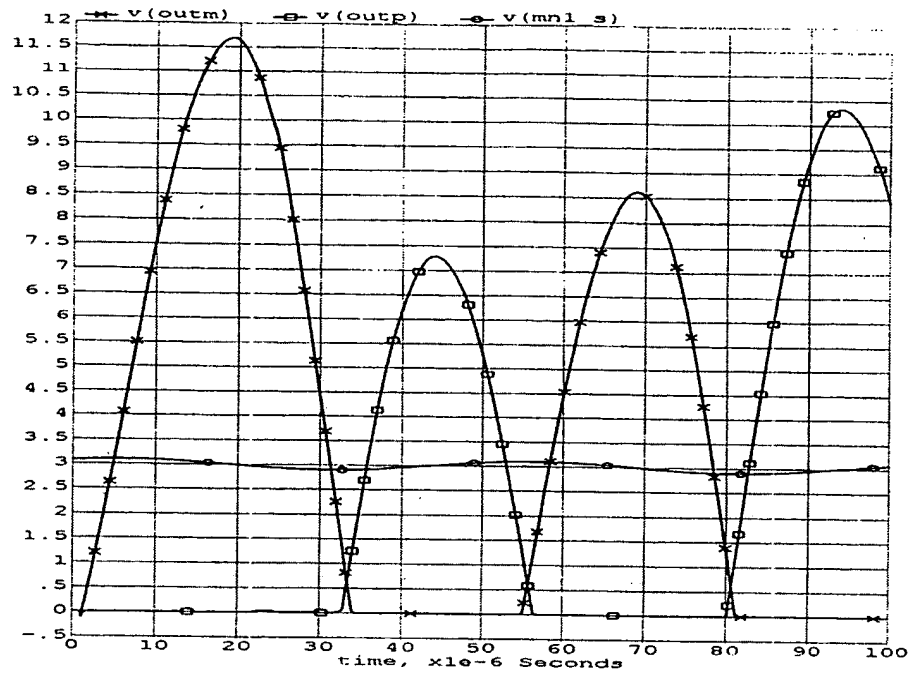


Figure 6

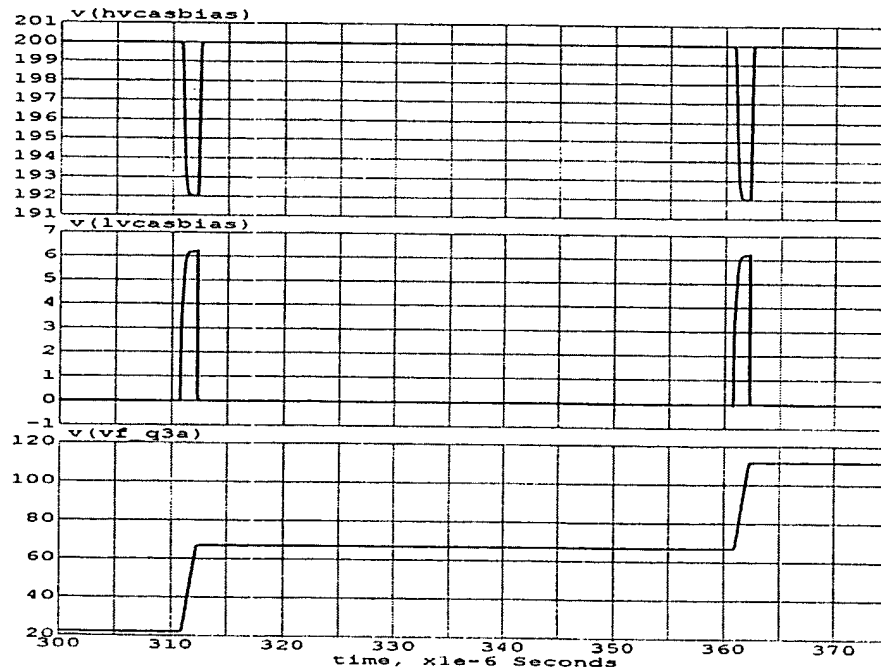


Figure 7

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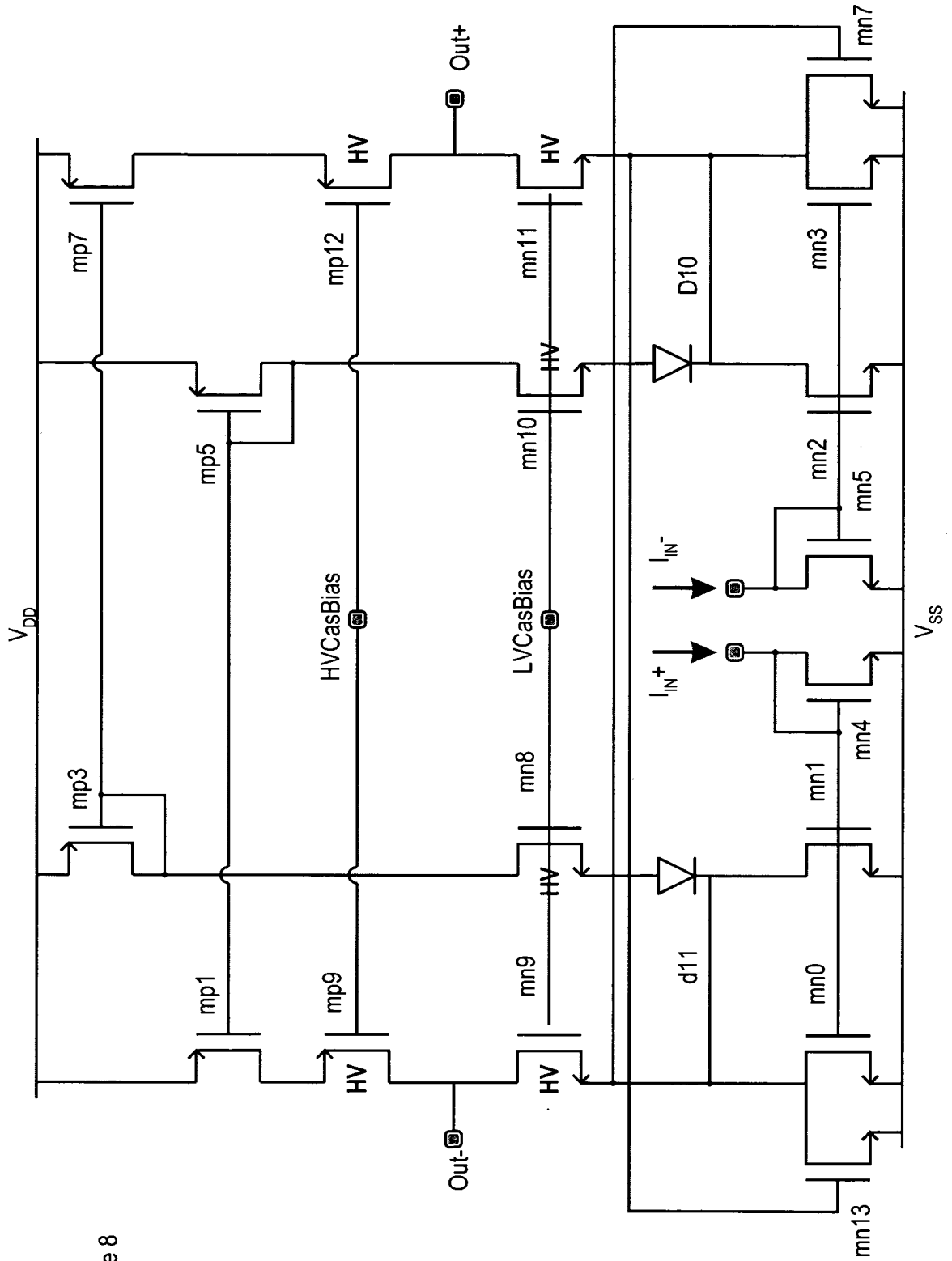


Figure 8

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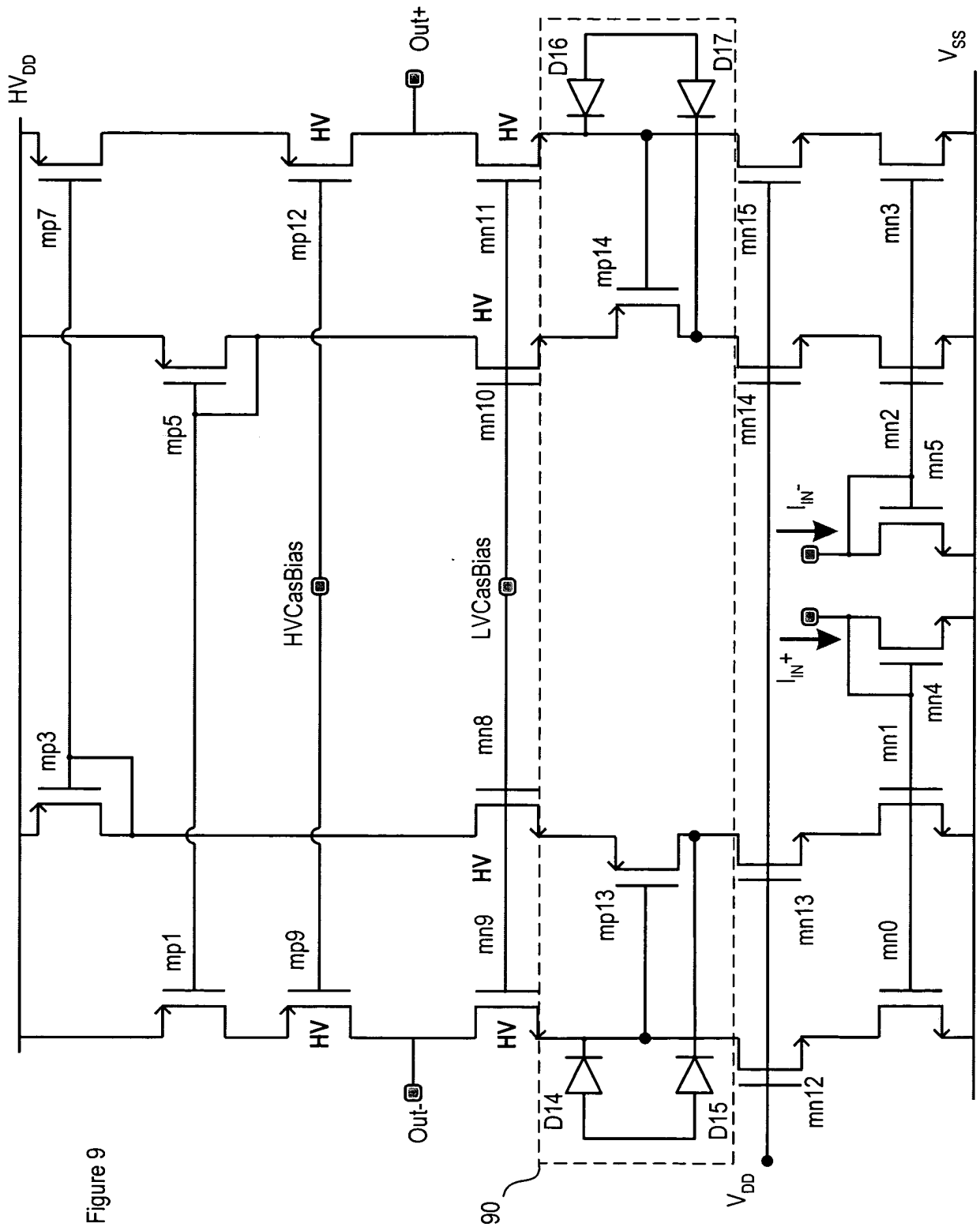


Figure 9